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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Allen et al
U.S. Serial No. : 09/931,339
Filing Date : August 16, 2001
For : RADIATION-CURABLE SILICONE ELASTOMERS
Group Art Unit : N/A

745 Fifth Avenue
New York, New York 10151

I hereby certify that this correspondence is being
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Commissioner of Patents and Trademarks,
Washington, D.C. 20231, on January 25, 2001

William F. Lawrence, Registration No. 28,029

Name of Applicant, Assignee or
Registered Representative

William F. Lawrence
Signature

January 25, 2001
Date of Signature

INFORMATION DISCLOSURE STATEMENT

RECEIVED
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TC 1700 MAIL ROOM

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Enclosed are copies of publications the subject matters
of which are mentioned in the specification for the Examiner's
review:

1. US 4,587,159, May 6, 1986, Gutek et al;
2. US 5,004,643, April 2, 1991, Caldwell;

3. US 5,209,965, May 11, 1993, Caldwell;
4. US 5,418,051, May 23, 1995, Caldwell;
5. US 4,666,765, May 19, 1987, Caldwell et al;
6. US 4,978,726, December 18, 1990, Döhler et al;
7. US 5,494,945, February 27, 1996, Kidon et al;
8. US 5,391,405, February 21, 1995, Irifune et al;
9. US 5,494,979, February 27, 1996, Ebbrecht et al;
10. US 5,863,966, January 26, 1999, Ebbrecht et al;
11. US 4,675,346, June 23, 1987, Lin et al;
12. US 4,929,647, May 29, 1990, Burger et al;
13. US 4,963,438, October 16, 1990, Weitemeyer et al;
14. US 4,940,766, July 10, 1990, Gay et al;
15. US 4,575,546, March 11, 1986, Klemarczyk et al;
16. US 4,575,545, March 11, 1986, Nakos et al;
17. US 5,091,483, February 25, 1992, Mazurek et al;
18. US 6,211,322, April 3, 2001, Döhler et al;
19. US 5,552,506, September 3, 1996, Ebbrecht et al;
20. US 4,271,425, June 2, 1981, Wong.

We have enclosed a copy of PTO-1449 in duplicate which is considered part of the Information Disclosure Statement.

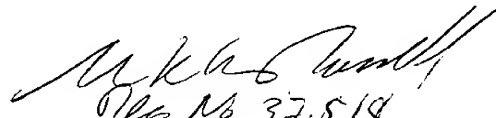
This Information Disclosure Statement is being submitted prior to receipt of a first Office Action, so no fee is deemed

necessary. However, if a fee is required, the Examiner is hereby authorized to charge our Deposit Account 50-0320.

Applicant respectfully requests that the Examiner consider and make of record the documents cited herein and that a copy of Form PTO-1449 be initialed by the Examiner and returned to the undersigned.

Respectfully submitted,

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